

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit:

Examiner:

File No.: H0004479

In re Application of: Andrew J. Poss, et al

Serial No.: 10/697,347

Filed: October 30, 2003

For: Fluorinated Polymers

Morristown, NJ

June 10, 2004

Hon. Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(c)

Dear Sir:

In accordance with the duty of disclosure under 37 C.F.R. §1.56, Applicants hereby notify the U.S. Patent and Trademark Office of the documents which were cited in the Search Report in the corresponding PCT application and are listed on the attached PTO-1449 Form. The Examiner may deem these documents to be relevant to patentability of the claims of the above-identified application. A copy of each publication is enclosed for convenience of the Examiner, as well as a copy of the Search Report.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicants do not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

Applicants respectfully request that the listed documents be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO-1449 be returned in accordance with MPEP \$609.

With regard to the statement under 37 CFR 1.97 (e), the undersigned states that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,

Andrew J. Poss, et al

By:

Registration No. 44,611

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Enclosures

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Certificate of Mailing Under 37 CFR § 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 22, 2004

Dana Deinstadt

Date: June 10, 2004

FORM PTO-1 (Rev. 2-32)		ENT OF COMMEI RADEMARK OFF		NO: SERIAL NO.: 10/697,347				
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			APPLICANT: Andrew J. Poss et al.					
JUN 1 4 2004				GROUP:	GROUP:			
A RES	7	U.S. PAT	ENT DOCUMENTS		-			
INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS		DATE IF PRIATE	
	6,468,712 B1	10/22/02	Fedynyshyn et al.					
		EODEICN D	ATENT DOCUMENTS					
		FOREIGNT	ATENT DOCUMENTS			TRANSI	LATION	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO	
	WO 03/073169	9/4/03						
	DE 41 04 392 A WO 00/67072	8/20/92						
	WO 00/07072	11/9/00						
			ng Author, Title, Date, Per		<u> </u>			
		Vohra, Vaishali R. et al., "Highly Transparent Resist Platforms for 157-nm Microlithography: An Update" Proceedings of SPIE, 4690, pp. 84-93(2002)						
			, "Resist Materials for 157 r 45, pp. 385-395(2001)	nm Microlitho	ography: An	Update"		
	McBe	e, Earl T et al., "St	tereochemistry of the Diels- vatives with Cyclopentadier					
	632-63	36 (1973)	Novel Trifluoromethylation					
	by an	Electrogenerated E	Base" J. Org. Chem., Vol. 5	6, pp. 2-4 (19	91)			
	Deterr 45, pp	nination of Absolu . 1379-1382 (1980		s and Oxaziri	dines" J. Org		, Vol.	
			USSR, Vol. 38, No. 3, pp. Amer. Chem. Soc., Vol. 84					
			Chem. Soc., Vol. 77, p. 917		113 (1902)			
			g. Chem., Vol. 44, pp. 3485		<u></u>			
EXAMINER			DATE CONSII	DERED				
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Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.